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Application Serial No. 10/087,510
Amendment dated April 13, 2004
Response to Office Action dated January 14, 2004



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/087,510
Applicants : SETHURAMAN JAYASHANKAR ET AL
Filed : March 1, 2002
Title : SINGLE LAYER RESIST LIFT-OFF
PROCESS AND APPARATUS FOR
SUBMICRON STRUCTURES

Group Art Unit : 1765
Examiner : Shamim Ahmed

Docket No. : 011333

I hereby certify that this
correspondence is being deposited with
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Commissioner for Patents, P.O. Box
1450, Alexandria, Virginia 22313-1450
on

this 13th day of April, 2004.

Bea MacDonald
Buchanan Ingersoll, P.C.

AMENDMENT

Pittsburgh, Pennsylvania 15219

April 13, 2004

Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to Office Action dated January 14, 2004, please amend this application as set forth hereinafter.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.